



Docket No.: M-10693 US



June 26, 2001

Box Patent Application Commissioner For Patents Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventors:	Steve Biellak, Stanley E. Stokowski and Mehdi Vaez-Iravani						
Title:	SYSTEMS AND METHODS FOR A WAFER INSPECTION SYSTEM USING MULTIPLE ANGLES AND MULTIPLE WAVELENGTH ILLUMINATION						
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$\frac{X}{X}$	This Transmittal Letter (in duplicate)
14_	pages Specification (not including claims)
8	pages Claims
1	page Abstract
3_	Sheets of Drawings
4	pages Declaration For Patent Application and Power of Attorney
$ \begin{array}{c} \frac{1}{3} \\ \underline{4} \\ \underline{1} \\ \underline{2} \\ \boxed{3} \end{array} $	page Recordation Form Cover Sheet (in duplicate)
2	pages Assignment
3	pages Information Disclosure Statement and PTO Form 1449 citing 21 references
	Copies of 21 Cited References submitted

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	<u>CLAIMS AS FILED</u>									
		Number			Number					Basic Fee
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in in	Total fee for filing the patent application in the amount of The Commissioner is hereby authorized to charge any additional fees which may be									1,240.00

EXPRESS MAIL LABEL NO:

required, or credit any overpayment to Deposit Account 19-2386.

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Respectfully submitted,

Rahul D. Engineer Attorney for Applicants Reg. No. 47,548